

Docket No.: 245156US3CIP

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/706,915

Applicants: Tsutomu OKABE, et al. Filing Date: November 14, 2003

For: WAFER PROCESSING APPARATUS HAVING

**DUST PROOF FUNCTION** 

Group Art Unit: 1763 Examiner: MOORE, K.

SIR:

Attached hereto for filing are the following papers:

## Request for Reconsideration

Our credit card payment form in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Surinder Sachar

Gregory J. Maier

Registration No. 25,599

Kevin M. McKinley Registration No. 34,423

Registration No. 43,794

OBLON
SPIVAK
MCCLELLAND
MAIER
A
NEUSTADT

ATTORNEYS AT LAW

P.C.

GREGORY J. MAIER (703) 413-3000 GMAIER@OBLON.COM

KEVIN M. MCKINLEY (703) 413-3000 KMCKINLEY@OBLON.COM \*BAR OTHER THAN VIRGINIA

(703) 413-2220 (fax) I:\atty\KMM\Prosecution Work\245156\PTO Cover Ltr.doc

Customer Number

(703) 413-3000 (phone)



## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

TSUTOMU OKABE, ET AL. : EXAMINER: MOORE, K.

SERIAL NO: 10/706,915

FILED: NOVEMBER 14, 2003 : GROUP ART UNIT: 1763

FOR: WAFER PROCESSING

APPARATUS HAVING DUST PROOF

**FUNCTION** 

## **REQUEST FOR RECONSIDERATION**

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated June 23, 2006, reconsideration of the aboveidentified application is respectfully requested.

Remarks/Arguments begin on page 2 of this paper.